Attorney's Docket No. 9180-9

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Glenn A. Rinne

not yet assigned Serial No.:

Filed:

concurrently herewith

For:

METHODS OF POSITIONING COMPONENTS USING LIQUID PRIME MOVERS

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AND RELATED STRUCTURES

Date: November 9, 2001

PATE

Commissioner for Patents Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a list of documents on form PTO-1449 together with a copy of each identified document. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.97 and Section 609 of the MPEP. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

Respectfully submitted

Registration No. 38,176

Correspondence Address:

PATENT TRADEMARK OFFICE

"Express Mail" mailing label number EL 920740102 US Date of Deposit: November 9, 2001

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to Box, Commissioner of Patents, Washington, DC 20231.

PORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office LIST OF DOCUMENTS CITED BY APPLICANT (Use several sheets if necessary)					Attorney Docket Number 9180-9 Applicants: Glenn A. Rinne			Serial No. not yet assiged
								10/01
					Filing Date concurrently herewith			Group
			U. S.	PATENT D	OCUMENTS			
Examiner Initial		Document Number Date			Name	Class	Subclass ·	Filing Date if Appropriate
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	<u>.l.</u>		FOREI	GN PATEN	T DOCUMENTS	3		
		Document Number	Date		Country	Class	Subclass	Translation Yes No
		OTHER DO	CUMENTS (I	ncluding Au	thor, Title, Date,	Pertinent Page	es, Etc.)	
	1.	A Powell et al:	Mechanism o	f Motion of a	<i>in Optical Fiber</i> Iaterials Researc	Aligned by a S	older Droplet	; Mat. Res. Soc.
	2.	Effect of Temperature on Surface Tension; Intelligent Systems Laboratory, Michigan State University, 1999 pp 1-2.						
	3.	Ki-Chang Song et al; Micromachined Silicon Optical Bench for the Low Cost Optical Module. Phillip G. Wapner et al; Utilization of surface tension and wettability in the design and operation of microsensors; Sensors and Actuators B71 (2000) pp 60-67						
	4.							
	5. R.R.A. Syms et al; Improving yield, accuracy and complexity in surface tension self-assesses Sensors and Actuators A 88 (2001) pp 273-283.							
	6.	Junghoon Lee at al; Surface-Tension-Driven Microactuation Based on Continuous Electrowetting; Journal of Microelectromechanical Systems, Vol. 9, No. 2. June 2000, pp 171-180.						
	7.	Junghoon Lee Process.	et al; Microac	tuation by C	ontinous Electro	wetting Phenor	nenon and Sil	licon Deep RIE

EXAMINER EXAMINER

DATE CONSIDERED